

Electronic Acknowledgement Receipt

EFS ID:	1419649
Application Number:	10776228
International Application Number:	
Confirmation Number:	2636
Title of Invention:	Method of manufacturing nitride semiconductor light emitting device
First Named Inventor/Applicant Name:	Je Won Kim
Correspondence Address:	LOWE HAUPTMAN GILMAN & BERNER, LLP - Suite 310 1700 Diagonal Road Alexandria VA 22314 US - -
Filer:	Benjamin J. Hauptman/Ayesha Wilson
Filer Authorized By:	Benjamin J. Hauptman
Attorney Docket Number:	2336-241
Receipt Date:	05-JAN-2007
Filing Date:	12-FEB-2004
Time Stamp:	15:24:04
Application Type:	Utility

Payment information:

Submitted with Payment	no
------------------------	----

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Amendment - After Non-Final Rejection	2007-01-05-Response.pdf	278351	no	9
Warnings:					
Information:					
Total Files Size (in bytes):			278351		
<p>This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.</p> <p><u>New Applications Under 35 U.S.C. 111</u> If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.</p> <p><u>National Stage of an International Application under 35 U.S.C. 371</u> If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.</p>					